Attorney Docket No.: Q75284 AMENDMENT UNDER 37 C.F.R. § 1.111

Application No.: 10/553,395

AMENDMENTS TO THE CLAIMS

This listing of claims will replace all prior versions and listings of claims in the

application:

LISTING OF CLAIMS:

1. (currently amended): A substrate for use in a perpendicular magnetic recording

medium, comprising a blank substrate and a soft magnetic layer comprised of a film of

phosphorus- or boron-containing cobalt alloy formed on the blank substrate by electroless

plating, the electroless plated film of the cobalt alloy having surface roughness Ra in the range of

0.05 nm to 1 nm.

2. (currently amended): The substrate for use in a perpendicular magnetic recording

medium according to Claim 1, wherein a number of defects occurring on a surface of the

electroless plated film of the cobalt alloy and measuring 0.1 µm or more in diameter and 7 nm or

more in depth is less than 5 per surface corresponding to a surface on one side of a substrate

having a diameter of 2.5 inches.

3. (currently amended): The substrate for use in a perpendicular magnetic recording

medium according to claim 1, wherein a number of projections occurring on the surface of the

electroless plated film of the cobalt alloy and measuring 0.1 µm or more in diameter and 7 nm or

more in height is less than 5 per surface corresponding to a surface on one side of a substrate

having a diameter of 2.5 inches.

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4. (original): The substrate for use in a perpendicular magnetic recording medium according to any one of claims 1 to 3, wherein the electroless plated film of the cobalt alloy has a phosphorus content in the range of 1 mass% to 30 mass%.

- 5. (original): The substrate for use in a perpendicular magnetic recording medium according to any one of claims 1 to 3, wherein the electroless plated film of the cobalt alloy has a boron content in the range of 0.1 mass% to 10 mass%.
- 6. (currently amended): The substrate for use in a perpendicular magnetic recording medium according to claim 1 any one of claims 1 to 5, wherein the electroless plated film of the cobalt alloy has a thickness in the range of 0.1 μ m to 5 μ m.
- 7. (currently amended): A method for the production of a substrate for use in a perpendicular magnetic recording medium, comprising a step of forming on a blank substrate a soft magnetic layer comprised of a film of phosphorus- or boron-containing cobalt alloy by electroless plating and a step of polishing a surface resulting from the step of forming the film by the plating.
- 8. (original): The method for the production of a substrate for use in a perpendicular magnetic recording medium according to claim 7, wherein the polishing step removes the electroless plated film of the cobalt alloy in a depth in the range of 0.15 μ m to 10 μ m and thins the electroless plated film of the cobalt alloy to a thickness in the range of 0.1 μ m to 5 μ m.

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9. (original): The method for the production of a substrate for use in a perpendicular magnetic recording medium according to claim 7 or 8, wherein the polishing step uses polishing liquid containing water and abrasive grains and further contains at least one member selected from the group consisting of an oxidizing agent, a chelating agent and a pH-adjusting agent.

- 10. (original): The method for the production of a substrate for use in a perpendicular magnetic recording medium according to claim 9, wherein the polishing liquid has a pH value in the range of 3 to 9.5.
- 11. (currently amended): The method for the production of a substrate for use in a perpendicular magnetic recording medium according to claim 9-or 10, wherein the abrasive grains contained in the polishing liquid have a concentration in the range of 1 mass% to 30 mass%.
- 12. (currently amended): The method for the production of a substrate for use in a perpendicular magnetic recording medium according to <u>claim 9</u> any one of claims 9 to 11, wherein the abrasive grains contained in the polishing liquid are SiO₂ grains having an average particle diameter (D50) of 20 nm or less.
- 13. (currently amended): The method for the production of a substrate for use in a perpendicular magnetic recording medium according to <u>claim 9</u> any one of claims 9 to 12, wherein the oxidizing agent contained in the polishing liquid is hydrogen peroxide.

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14. (currently amended): The method for the production of a substrate for use in a perpendicular magnetic recording medium according to <u>claim 9any</u> one of claims 9 to 13, wherein the chelating agent contained in the polishing liquid contains at least one compound selected from the group consisting of EDTA, citric acid and succinic acid.

- 15. (currently amended): The method for the production of a substrate for use in a perpendicular magnetic recording medium according to <u>claim 9</u> any one of claims 9 to 14, wherein the pH-adjusting agent contained in the polishing liquid contains at least one member selected from the group consisting of aqueous ammonia, water-soluble organic acid and salts thereof.
- 16. (new): The substrate for use in a perpendicular magnetic recording medium according to claim 1, wherein the electroless plated film is a film that does not contain a magnetic wall.
- 17. (new): The substrate for use in a perpendicular magnetic recording medium according to claim 4, wherein the phosphorus content is in the range of 1 mass% to 10 mass%.
- 18. (new): The substrate for use in a perpendicular magnetic recording medium according to claim 1, wherein the electroless plated film of the cobalt alloy has a phosphorus content in the range of 3 mass% to 15 mass%.

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19. (new): The substrate for use in a perpendicular magnetic recording medium according to claim 1, wherein the electroless plated film of the cobalt alloy has a phosphorus content in the range of 3 mass% to 10 mass%.